

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takaaki NODA et al.

ATTN: **Mail Stop PCT**

Application No.: 10/587,500

Docket No.: 128807

Filed: July 27, 2006

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND  
APPARATUS FOR PROCESSING SUBSTRATE**

**NOTIFICATION OF ACCEPTANCE AND FILING RECEIPT STATUS REQUEST**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

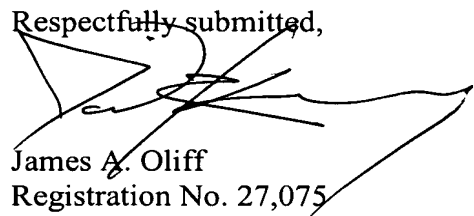
Sir:

The above-captioned patent application entered the National Phase on July 27, 2006. The 35 U.S.C. 371 requirements were completed on July 27, 2006.

The original Notification of Acceptance and Filing Receipt have not yet been received. It is respectfully requested that the original Notification of Acceptance and Filing Receipt be immediately forwarded to the attorneys of record at the address set forth below.

If there are any questions regarding this matter, please contact the undersigned at the telephone number set forth below.

Respectfully submitted,

  
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Date: December 27, 2006

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